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Substitute for form 1449A/B/PTO  <b>INFORMATION DISCLOSURE STATEMENT BY APPLICANT</b>  <i>(Use as many sheets as necessary)</i>				<b>Complete if Known</b>	
				Application Number	NEW PCT/PTO 10/15/2008 96
				Filing Date	Concurrently Herewith
				First Named Inventor	Renato BUGGE
				Art Unit	N/A
				Examiner Name	Not Yet Assigned
				Attorney Docket Number	BRW-002US
Sheet	1	of	1		

U.S. PATENT DOCUMENTS					
Examiner Initials*	Cite No. <sup>1</sup>	Document Number	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number-Kind Code <sup>2</sup> (if known)			
/JL/	A1	US-5,577,061 A	11-19-1996	Thomas C. Hasenberg et al.	

FOREIGN PATENT DOCUMENTS						
Examiner Initials*	Cite No. <sup>1</sup>	Foreign Patent Document	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T <sup>6</sup>
		Country Code <sup>3</sup> -Number <sup>4</sup> -Kind Code <sup>5</sup> (if known)				
	A2	WO 92/7361 A1	02-28-2002	The Regents of the University of California		
	A3	JP 52055993 B	09-12-1977	Matsushita Elec Ind Co Ltd		
	A4	SU 784625 B	01-20-1982	AS USSR RADIO ELTRN		
	A5	GB 1495802 A	10-15-1996	AS USSR RADIO ELTRN		
	A6	CN 1328175 A	12-26-2001	Shanghai Metallurgy Inst Chinese Acad Sc		

\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant. <sup>1</sup> Applicant's unique citation designation number (optional). <sup>2</sup> See Kinds Codes of USPTO Patent Documents at [www.uspto.gov](http://www.uspto.gov) or MPEP 901.04. <sup>3</sup> Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). <sup>4</sup> For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. <sup>5</sup> Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST.16 if possible. <sup>6</sup> Applicant is to place a check mark here if English language Translation is attached.

NON PATENT LITERATURE DOCUMENTS			
Examiner Initials*	Cite No. <sup>1</sup>	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T <sup>2</sup>
	A7	JIAN GU ZHOU et al. "Study of a new etchant for GaSb/AlGaAsSb device fabrication" Journal of functional materials and devices, 2001, Vol. 7, No. 1, p. 81-84	
	A8	Werner et al. "InGaAsSb-AlGaAsSb Distributed Feedback Lasers Emitting at 1.72 um" IEEE PHOTONICS TECHNOLOGY LETTERS, 8 August 2000, Vol. 12, No. 8, p. 966-968 (especially p.966)	

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Examiner Signature	/Jonathan Langman/	Date Considered	06/12/2008
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